



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Application of:		I hereby certify that this paper is being deposited with th
Applicant(s):	Hotta et al.	United States Postal Service as FIRST-CLASS mail in a envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, of this date. May 25, 2007 Date Attorney for Applicant(s)
Serial No.:	10/612,385	
Conf. No.:	3186	
Filed:	July 2, 2003	Registration No. 47,954
METHO SAME,	ILM TRANSISTOR DEVICE, DD OF MANUFACTURING THE AND THIN FILMTRANSISTOR RATE AND DISPLAY HAVING AME	
Art Unit:	2811	
Examiner:	Hu, Shouxiang	

AMENDMENT I

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-150

Dear Sir:

In response to the final Office Action mailed February 26, 2007, please enter the following amendments to the above-identified Application: